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Girou, D.A.

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David Alain Girou

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Promotor:	Prof. dr. M.W. Beijersbergen
Copromotor:	Prof. dr. M.A.G.J. Orrit
Promotiecommissie:	Dr. M. Bavdaz (ESA-ESTEC, Noordwijk, The Netherlands)
	Dr. D.D.M. Ferreira (DTU, Kgs. Lyngby, Denmark)
	Prof. dr. J. Aarts
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The front and back cover show stacks of thirty-five silicon plates directly bonded on top of each other, forming a pore-like structure. High-energy photons enter these pores at low grazing angles, where they are reflected on the reflective side of each plate, and exit the stack at the opposite end. Images are courtesy of cosine Research B.V.

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